Attorney Docket No.:

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Geoffrey T. Haigh and Baoxing Chen

Serial No:

09/838,520

Confirmation No.: Filed:

9453 April 19, 2001

For:

NON-OPTICAL SIGNAL ISOLATOR

Examiner:

R. Deberadinis

2836

rt Unit:

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with rst class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the day of February, 2003.

Reg. No. 27,900

COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

Sir:

## **AMENDMENT UNDER 37 CFR 1.116**

In response to the Final Action mailed October 18, 2002, kindly amend the aboveidentified application as follows:

## In the Specification:

Kindly amend the specification as indicated below, a marked-up copy of the indicated paragraphs of the original specification being attached hereto with the title "Marked-Up Specification."

On page 4, replace the paragraph at lines 3-6 with the following:

The isolation barrier may be formed on one or two silicon die and can be formed from other passive elements such as two pairs of capacitor plates, or two pairs of (coil) windings, in each case preferably creating a vertical structural arrangement with a dielectric (and in the case of windings, a Faraday shield) between the passive elements.

Beginning on page 6, line 32, replace the paragraph with the following: